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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	<i>[1]</i>	/
Bohr, Mark T.)	
U.S. Serial No: 09/002,178) Examiner: Guerrero, Maria F.	
Filed: December 31, 1997) Art Unit: 2822	
For: WAFER PASSIVATION STRUCTURE AND METHOD OF FABRICATION	0CT TC 2800	7
Assistant Commissioner for Patents Washington, D.C. 20231	T-3 2002	

PRELIMINARY AMENDMENT

Dear Sir:

Please enter the enclosed Preliminary Amendment and consider the following remarks prior to examination of the above-referenced case.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

on September 25, 2002

Date of Deposit

Teresa Edwards

Name of Person Mailing Correspondence

Suffluer 25, 2002

Signature

Date